

AUG. 21, 2002 1:04PM

ON PEABODY

NO. 3109 P. 3

Docket No. 0819-0559

- 1 -

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shin HASIMATO et al.) Attn: Customer Correction Branch
Serial No. 09/856,823)
Filed: May 25, 2001)
For: METHOD FOR FABRICATING)
SEMICONDUCTOR DEVICE)

Attention: Application Processing Division

REQUEST FOR CORRECTED FILING RECEIPT

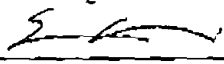
Honorable Commissioner of Patents
Washington, D.C. 20231

Sir:

The Filing Receipt received in the above-identified application has errors thereon due to Patent Office error as shown in red on the attached copy.

In view of the above, it is requested that a Corrected Filing Receipt be issued.

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

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(703) 790-9110

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NO. 3189 P. 1



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NO. 3109 P. 2

This will acknowledge receipt of the following:

1. Transmittal Form
2. Request for Corrected Filing Receipt
3. Request for Consideration of Documents Cited in International Search Report

In re PATENT application of:

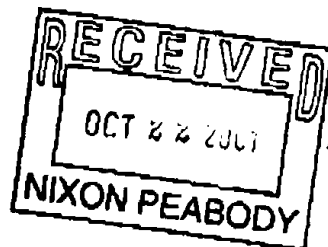
SHIN HASHIMOTO et al
Serial No. 09/856,823
Filed: 05/25/2001
Due Date: 11/25/2002
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Docket: 740819-000559
October 19, 2001
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